

RECEIVED  
CENTRAL FAX CENTER

FEB 05 2005

Customer No.: 31561  
Application No.: 10/064,703  
Docket No.: 9458-US-PA

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application )  
Application 10/064,703 )  
Filed: August 8, 2002 )  
For: METHOD FOR DEPOSITING THIN FILM USING PLASMA )  
CHEMICAL VAPOR DEPOSITION )  
  
Applicant: Frank Lin )  
Examiner: Meeks, Timothy Howard )  
Art Unit 1762 )

---

*No fee is believed to be due. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.9458-US-PA)*

**Preliminary Amendment**

U.S. Patent and Trademark Office  
Commissioner for Patents  
220 20th Street South  
Customer Window, Mail Stop RCE  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, Virginia 22202

Dear Sir:

Prior to the examination on merits, please amend the above-identified application as follows: